

INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)

U.S. PTO
09/842403
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Atty. Docket No.	04329.2566	Serial No.	09/842403 Not Yet Assigned
Applicant	Shinichi ITO et al.		
Filing Date	April 26, 2001	Group	2823
U.S. PATENT DOCUMENTS			
Examiner Initial*	Document Number	Date	Name
ME	6,066,575	5/23/2000	Reardon et al.
ME	6,162,745	12/19/2000	Ito et al.
FOREIGN PATENT DOCUMENTS			
	Document Number	Date	Country
no translation	9-320950	12/12/97	Japan
	2000-150352	5/30/2000	Japan
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)			
	ITO et al., "LIQUID FILM FORMING METHOD", US Patent Application Serial No. 09/669,725, filed September 26, 2000.		
	ITO et al., "APPARATUS AND METHOD OF FORMING LIQUID FILM". US Patent Application Serial No. 09/335,508, filed December 20, 2000.		
	IKEGAMI, et al., "DEPOSITION APPARATUS", US Patent Application Serial No. 09/817,196, filed March 27, 2001.		
Examiner	Michelle Estrada		Date Considered 11/25/02
*Examiner:	Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.		
Form PTO 1449		Patent and Trademark Office - U.S. Department of Commerce	



INFORMATION DISCLOSURE
CITATION

Atty. Docket No.

Serial No.

4329.2566

09/842,403

Applicant

Ito et al.

Filing Date

Group

April 26, 2001

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U.S. PATENT DOCUMENTS

*Examiner Initial	Document Number	Date	Name	Class	Sub- Class	Filing Date

FOREIGN PATENT DOCUMENTS

*Examiner Initial	Document Number	Date	Country	Class	Sub- Class	Translation	
						Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

<i>ME</i>	Copy of U.S. Patent Application Serial No. 09/735,553, filed December 14, 2000 to Ema et al.

Examiner

Michelle Estrada

Date Considered

11/25/02

- * Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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Atty. Docket No.	04329.2566	Serial No.	09/842,403
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U.S. PATENT DOCUMENTS

Examiner Initial*	Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate

FOREIGN PATENT DOCUMENTS

	Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No
<i>ME</i>	JP 02-220428 A	09/1990	Japan	—	—	English Abstract
<i>ME</i>	JP 06-151295 A	05/1994	Japan	—	—	English Abstract
<i>ME</i>	JP 07-321001 A	12/1995	Japan	—	—	English Abstract
<i>ME</i>	JP 2000-077326 A	03/2000	Japan	—	—	English Abstract

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner	<i>Michelle Estrada</i>	Date Considered	11/25/02
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